

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Luo et al.

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING
PROTECTIVE LAYERS ON
SEMICONDUCTOR DEVICE
COMPONENTS SO AS TO REDUCE OR
ELIMINATE THE OCCURENCE OF
DELAMINATION THEREOF AND
CRACKING THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US
(02-1124.01/US)

VIA ELECTRONIC FILING
November 21, 2007

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment follows the Office Action of August 21, 2007, the shortened statutory period for response to which expires on November 21, 2007.

A listing of claims, in which amendments to the claims are presented, begins on page 2 of this paper; and

Remarks start at page 7 of this paper.